

high-resolution hardware systems may improve the control performances of distributed parameter systems featuring piezofilm actuators and sensors.

References

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Errata

Diverging Solutions of the Boundary-Layer Equations near a Plane of Symmetry

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BECAUSE of an error in the production process, the expression for $w_z(x)$ at the top of page 1923 appeared incorrectly. It should read

$$w_z(x) = A \cdot \exp[-(x - x_0)^2/B]$$

AIAA regrets this error.